

IFW



Docket No.: 060188-0807

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Osamu KUSUMOTO, et al. : Confirmation Number: 4190
Application No.: 10/801,606 : Group Art Unit: 2811
Filed: March 17, 2004 : Examiner: HU, Shouxiang

For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Noting the Office Action of June 30, 2005 wherein restriction has been required, Applicant hereby elects Group I and Species 1, the embodiment of Figures 1-2, and identifies claims 1-9 as reading thereon, for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Date: July 27, 2005